

PATENT  
Attorney Docket No. 5000-5108

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s) : Kyoichi KINOSHITA et al.  
Serial No : 10/615,432 Group Art Unit: 3742  
Filed : July 7, 2003 Examiner: Unassigned  
For : RADIATOR SYSTEM, RADIATING METHOD, THERMAL BUFFER,  
SEMICONDUCTOR MODULE, HEAT SPREADER AND  
SUBSTRATE

Mail Stop DD  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313

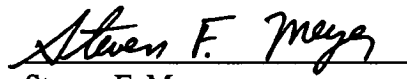
**CERTIFICATE OF MAILING (37 C.F.R. 1.8a)**

Sirs:

I hereby certify that the attached (1) Information Disclosure Statement, (2) PTO Form 1449, (3) Four references, (4) Communication dated January 26, 2004, (5) Return receipt postcard, and this Certificate of Mailing are being deposited with the United States Postal Service on date shown below with sufficient postage as first-class mail in an envelope addressed to Mail Stop DD, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313.

Respectfully submitted,

Dated: February 10, 2004

  
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